

Docket No.: 2336-257

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Seung Wan CHAE et al.

U.S. Patent Application No. 10/811,808

Filed: March 30, 2004

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: Confirmation No. 2845
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: Group Art Unit: 2814
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: Examiner: WAI SING LOUIE

For: GALLIUM NITRIDE (GaN)-BASED SEMICONDUCTOR LIGHT EMITTING DIODE AND
METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required. For the examiners information the references listed on the attached PTO/SB/08A were cited in closely related Application No. 10/812,015.

Respectfully submitted,
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U.S. PATENT
APPLICATION NO.
10/811,808

APPLICANT
Seung Wan CHAE et al.

FILING DATE
March 30, 2004

GROUP
2814

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	Abstract	Translation	Equivalent
	10/173224	6/1998	Japan		X	
	09/129919	5/1997	Japan		X	
	10/173222	6/1998	Japan		X	
	2001-035796	2/2001	Japan		X	
	09-129933	5/1997	Japan		X	
	10-341039	12/1998	Japan		X	
	08-032115	2/1996	Japan		X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Patent Abstracts of Japan – Publication No. 2001-035796, filed February 9, 2001

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.